

ATTORNEY DOCKET NO:72096

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : TAKAMATSU
Serial No : 10/565,879
Confirm. No : 7943
Filed : January 23, 2006
For : WAFER POLISHING METHOD
Art Unit : 1792
Examiner : GOUDREAU, GEORGE A
Dated : January 28, 2008

OK TO ENTER: /G.G./ (04/13/2008)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT AFTER FINAL REJECTION

In response to the Final rejection dated October 31, 2007, please amend the above
identified application as follows:

OK TO ENTER: /G.G./ (04/13/2008)